

JAN 13 2006

Docket No.: 2328-062

BEST AVAILABLE COPY**PATENT****IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of

Inventor(s): DHINDSA, Rajinder et al. : Confirmation No. 8414

U.S. Patent Application No. 10/645,665 : Group Art Unit: 1762

Filed: August 22, 2003 : Examiner: Marianne L. PADGETT

For: MULTIPLE FREQUENCY PLASMA ETCH REACTOR

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
 P.O. Box 1450
 Alexandria, VA 22313-1450

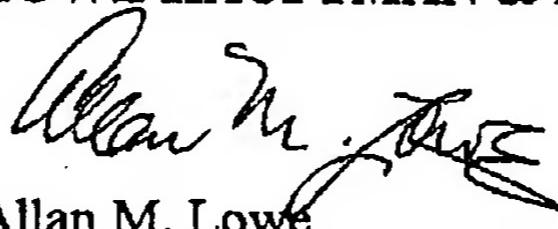
Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached form PTO-1449. It is respectfully requested that the documents be expressly considered during the prosecution of this application, and that the documents be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed before the mailing date of a first Office Action on the merits. No certification or fee is required.

Respectfully submitted,

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EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.